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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Tatsuya USAMI, et al.

Application No.: 10/763,847

Filed: January 23, 2004

For: **SEMICONDUCTOR DEVICE AND
METHOD FOR MANUFACTURING THE
SAME**

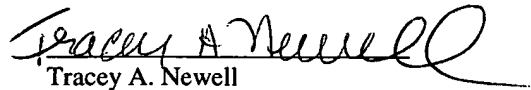
Art Unit: 2822

Examiner: POTTER, Roy Karl

Attorney Docket: PRM-00101

CERTIFICATE OF MAILING

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 2, 2005.


Tracey A. Newell

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

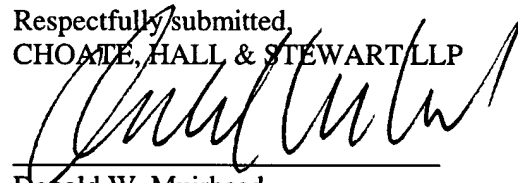
Sir:

In response to the Office Action dated April 5, 2005, in which restriction was required, Applicant elects Group I, claims 1-8, drawn to a semiconductor device.

Although we believe that we have appropriately provided for any fees due in connection with this submission, the Commissioner is hereby authorized to credit any overpayment or charge any deficiencies to/from our **Deposit Account No. 031721**. Two originally-executed copies of this form are being submitted.

Favorable consideration and allowance are earnestly solicited. Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at 617-248-4038.

Respectfully submitted,
CHOATE, HALL & STEWART LLP


Donald W. Muirhead
Reg. No. 33,978

May 2, 2005
Date

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